

EAST: [10627406 sublitho nanoscale memory.wsp:1]

File View Edit Tools Window Help

Pending

Active

- L1: (27187) (motorola IBM intel).as.
- L2: (66717) (motorola IBM intel "international business").as.
- L3: (2008) (microscal\$4 micro adj scal\$4 micrometerscal\$4 microscop\$4 micro adj s
- L4: (42) 2 and 3
- L5: (5381721) @ad > 20000101 @pd > 20020101
- L6: (6) 4 and 5
- L7: (59882) nanoscal\$4 nano adj scal\$4 nanometerscal\$4 nanoscop\$4 nano adj scop
- L8: (453) 7 adj2 (wir\$4 tube conducti\$4 memory)
- L9: (12) 8 and 2
- L10: (495) molecular adj3 memory
- L11: (800861) address\$4
- L12: (5) 10 near0 11
- L13: (60) 8. ti.
- L14: (117) 8. ab.
- L15: (40) 13 and 14

Failed

Saved

- (1) 09/048877
- (1736) "KONINKLIJKE PHILIPS".as.
- (0) 10/627406
- (497) "SRI International".as.
- (1057) sublithograph\$5 sub adj lithograph\$5 Extreme adj Ultraviolet adj Lithograph\$
- (1) 10/347121
- (4) 10.256.767.6.128.2141.on.

DBs: USPAT:US PGPUB:EPO:JPO:DERWENT:IBM:TDG

Default operator: GR

Plurals

Highlight all hit terms initially

13 and 14

June 2004

	U	1	Investor	Document	Issue	P	Title	Current	Current	Current	Retrieval	S	C	P	3	4	Image	Doc.	P
1			Lieber, Charl	US 2003008	20030	1	Nanoscale wires and related devices	257/9	257/E61.04			R	F	F	F	F	F	US 200300	
2			DeHon, Andre	US 2004011	20040	3	Sublithographic nanoscale memory architect	257/9				F	F	F	F	F	F	US 200401	
3			Lieber, Charl	US 2002013	20020	2	Nanoscale wire-based devices, arrays, and	257/316	257/E27.00			R	F	R	F	F	F	US 200201	
4			Musket, Ron	US 6444256	20020	7	Formation of nanometer size wires using infil	427/117	216/56			F	F	F	F	F	F	US 644425	
5			Ha, Jeong-Se	US 5880012	18990	5	Method for making semiconductor nanomete	438/484	257/E21.13			F	F	F	F	F	F	US 588001	
6			GI, JOKA et al	JP 2004050	20040	1	METHQD FOR MANUFACTURING NANO-ME					F	F	F	F	F	F	JP 200405	
7			YOKOMICHI, JP	2003292	20031	7	METHOD FOR PRODUCING AMORPHOUS NA					F	F	F	F	F	F	JP 200329	
8			YOKOMICHI, JP	2003292	20031	9	METHOD FOR PRODUCING AMORPHOUS NA					F	F	F	F	F	F	JP 200329	
9			CHOI, KYUNG	JP 2001102	20010	7	MANUFACTURING METHOD OF NANO-SCAL					F	F	F	F	F	F	JP 200110	
10			MATSUI, HIS	EP 1146013	20011	2	AMORPHOUS NANO-SCALE CARBON TUBE					F	F	F	F	F	F	EP 114601	

Ready

3/24/04